

PATENT ASSIGNMENT

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CONVEYING PARTY DATA	
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University of California, Berkeley	06/13/2011
RECEIVING PARTY DATA	
Name:	National Science Foundation
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PROPERTY NUMBERS Total: 1	
Property Type	Number
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REEL: 026524 FRAME: 0802

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Invention Title: Low-Temperature Formation of Polycrystalline Semiconductor Films via Enhanced Metal-Induced Crystallization

Inventor(s): Tsu-Jae King Liu, Joanna Lai, Frank W. DelRio, Roya Maboudian

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Patent or Application Serial No.: 12/651,036

Grant/Contract Number(s): DMI0304209, HR0011-06-1-0049

Foreign Applications filed/intended in (countries): _____

The invention identified above is a Subject Invention under **35 U.S.C. 200, et seq.**, and the Standard Patent Rights clause at **37 CFR 401.14, FAR 52.227-11** or **FAR 52.227-12** (if applicable) which are included among the terms of the above identified grant or contract award from the United State Government. This document is confirmatory of:

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Signed this 12 day of June, 20 11.

By Irvin J. Mettler, Ph.D.
(Institutional Business Official)

Irvin J. Mettler
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